

For high purity chemical handling applications in semiconductor processing applications

The F-Series includes pneumatic drive bellows pumps that are designed for use in the semiconductor manufacturing processes.

lwaki introduced the first designs over 20 years ago and has continually developed new products to keep up with rapidly changing market needs.

With over 20 different models available the quality and performance of our products has made them the preferred solution by device manufactures all over the world.

Their quality and performance are recognized and highly rated by device manufacturers all over the world.

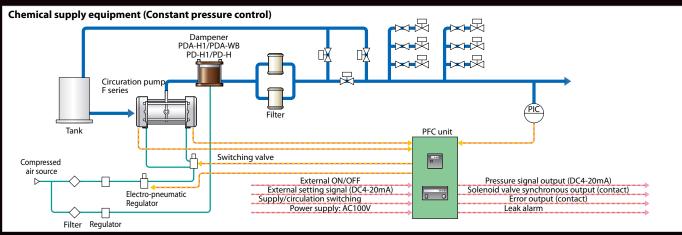
We offer not only pump solutions, but also accessories including controllers, dampeners, and liquid chemical supply systems that have been developed to compliment a comprehensive portfolio of quality equipment for wet process and surface preparation applications.

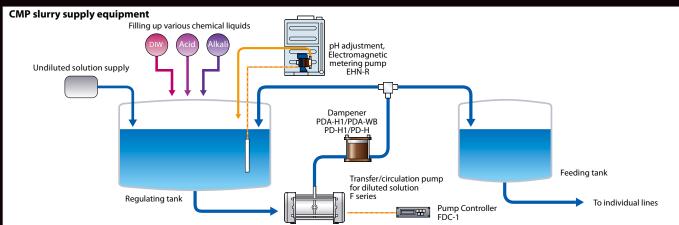


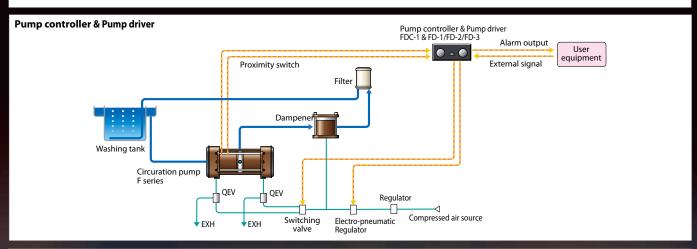
Application O Usable O Usable depend on condition FS-N FW-H FS-H CFD 0 0 0 0 0 0 0 Cleaning(Batch process) Wafer wet-bench 0 0 0 0 0 0 0 Cleaning(Single wafer) ◎ 0 0 0 0 Chemical supply equipment 0 0 0 0 0 Mixed-liquid circulation/Transfer CMP process 0 0 0 0 Cleaning Chemical repleshing equipment

^{*}Liquid temperature conditions vary depending on the pump specifications.

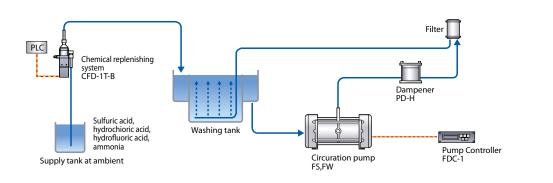
Example of installation







Wafer wet-bench



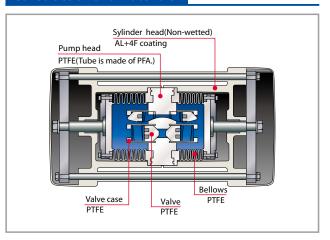


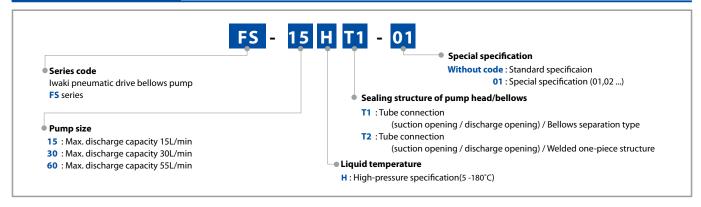
A small, lightweight and cost effective solution



- Using a higher stroke rate (240 spm maximum) has resulted in a reduction in size, weight and cost as well as reduced pulsation. Note: The maximum stroke rates are dependent on model and application; please refer to the specification table for details.
- All liquid contact components are constructed of high purity fluoroesin materials. The exterior of the units are also coated in fluoroesin so that no metallic components are exposed. FS-H pumps also utilize our own shaft seal design (patent pending) resulting in a marked reduction in particle generation.
- The pumps are rated for liquid temperatures ranging from 5 180 °C with discharge pressure to 0.45 MPa. Applications include wet process circulation and CMP processes, as well as chemical distribution feed systems.
- The FS-H body design eliminates the need for periodic tightening of the stud bolts. External access to the proximity sensors results in reduced maintenance and down time.
- The pump uses a proximity sensor drive system which opens/closes an external air solenoid valve providing easy performance control capabilities that are compatible with a variety of controller options.

Construction and materials

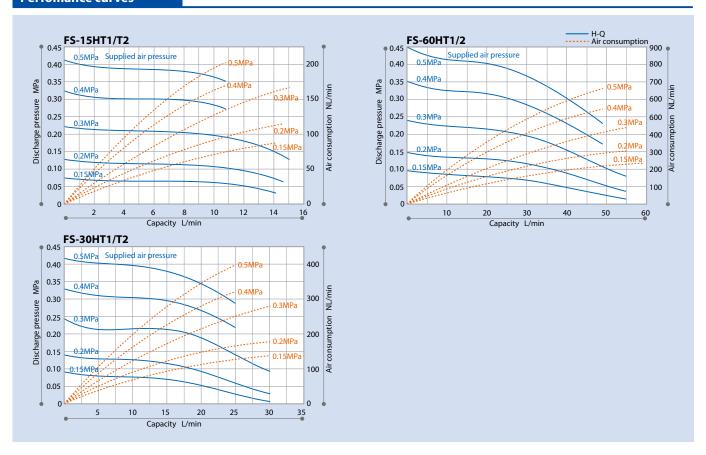




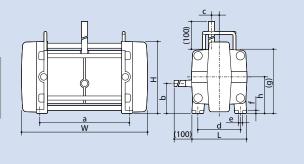
Model			FS-15HT1/T2			FS-30HT1/T2			FS-60HT1/T2		
Max. discharge capacity	L/min		15			30			55		
Air supply pressure range	MPa	0.15 – 0.5	0.15 – 0.3	0.15 – 0.2	0.15 – 0.5	0.15 – 0.3	0.15 – 0.2	0.15 – 0.5	0.15 – 0.3	0.15 – 0.2	
Liquid temperature range	°C	5 – 50	51 – 100	101 – 180	5 – 50	51 – 100	101 – 180	5 – 50	51 – 100	101 – 180	
Max. air consumption	NL/min	200	160	110	370	280	170	670	440	300	
Max. stroke speed*	spm		240		220			200			
Pump connection size			1/2" PFA tube		ø19xø16mm PFA tube			ø25xø22mm PFA tube			
Supply air connection size				Rc	1/4				Rc3/8		
Ambient temperature	°C	0 – 40									
Drive system					By proximity switch						

^{*180} spm maximum with feed air pressures between 0.3 and 0.5 MPa. Note: Max. discharge capacity shows when pumping clear water at 20°C.

Perfomance curves



Model	w	L	Н	а	b	c	d	e	f	g	h
FS-15HT1/T2	315	120	166	213	77	15.5	96	10	8	144	84
FS-30HT1/T2	390	151	208	272	93	23	115	10	9	180	105
FS-60HT1/T2	441	194	251	317	107	27	152	12	11	224	127



FS-100HT-2

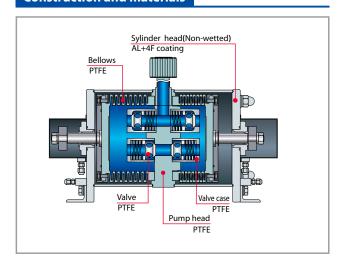
Flow and temperature capabilities offer improved process efficiencies

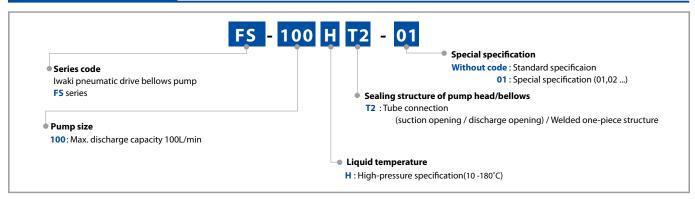
- Maximum flow rate of up to 100 L/min with 180°C liquid.

 This allows delivery of CARO (SPM) or H3PO4 at a flow rate 1.8 times higher than our existing pumps (55 L/min).
- Higher flow rates improve cleaning efficiency and removal of containments during wafer processing. Cleaning times are also reduced in systems with multiple processing lines.
- In addition to the use of fluoroplastic wet ends (PTFE and PFA), a fluorine coating on the pump's outer surfaces offers the best resistance to vapors from acid, alkali and hydrogen peroxide chemistries used in semiconductor manufacturing.
- Optimization of design has resultind in reduced weight of about 15% of our existing 80-100L models making installation and replacement work easier.
- The model adopts a sensor drive system that switches the solenoid valve using the proximity switch built into the pump. A leak sensor is also included as standard equipment.



Construction and materials

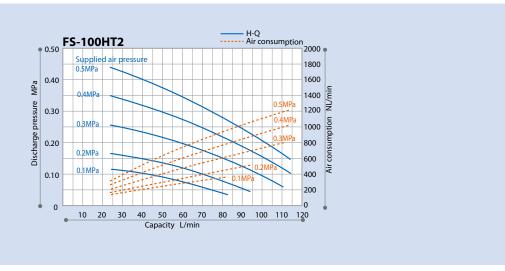


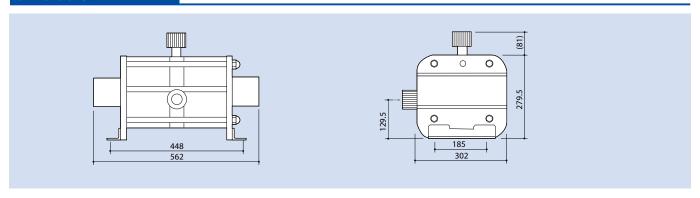


Model		FS-100HT2				
Max. discharge capacity	L/min	100				
Air supply pressure range	MPa	0.15 - 0.5	0.15 - 0.4	0.15 - 0.3		
Liquid temperature range	°C	10 - 100	101 - 140	141 - 180		
Max. air consumption	NL/min	1210				
Max. stroke speed	spm		120			
Pump connection size		1-1/4" fittings (SUPER 300-typ	e PILLAR FITTINGS manufactured by Nipp	on Pillar Packaging Co., Ltd.)		
Supply air connection size			Rc 1/2			
Allowable ambient temperature	۰C	0 - 60				
Drive system			By proximity switch			

Note: Max. discharge capacity shows when pumping clear water at 20°C.

Perfomance curves





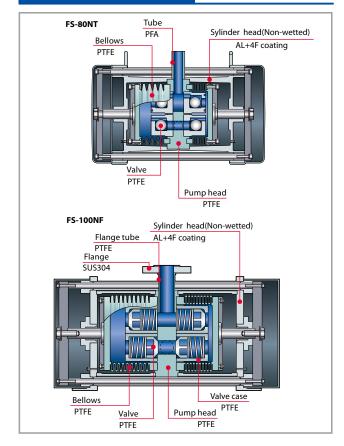


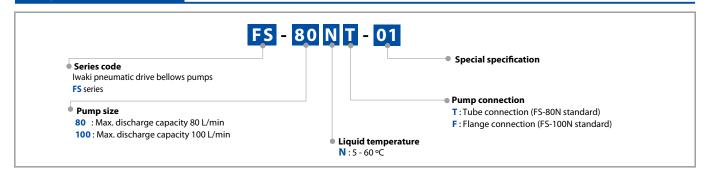
Max 100L/min. High flow design for chemical distribution applications

- Perfectly suited to high flow & pressure chemical distribution requirements.
- The high stroke rate (Max 200 SPM:FS-80NT) provides for a compact, lightweight and lower cost option without sacrificing flow and pressure capability.
- All liquid contact materials are made of high purity fluororesin resulting in contamination-free construction. Our unique patented shaft seal (FS-80NT...PAT.) also dramatically reduces particle generation.
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.
- Seal welded pump head and bellows eliminate leakage.



Construction and materials

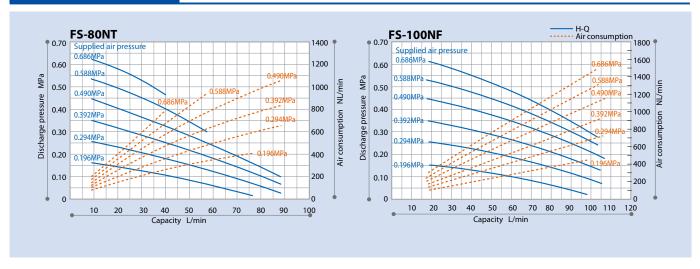


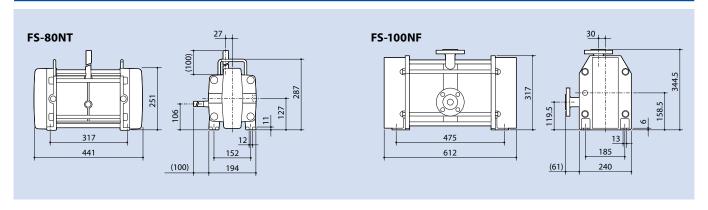


Model			FS-100NF		
Max. discharge capacity	L/min		100		
Air supply pressure range	MPa	0.25 - 0.5	0.5 - 0.6	0.6 - 0.7	0.2 - 0.7
Liquid temperature range	°C		5 - 60		5 - 50
Max. air consumption	NL/min	1029	938	787	1495
Max. stroke speed	spm	200	150	110	100
Self-priming height limit			1 m on more		1 m on more
Pump connection size			1" PFA tube		25A Flange
Wet-end materials			PTFE, PFA		PTFE,PFA
Supplied air connection size		Rc3/8			Rc1/2
Ambient temperature	°C	0 - 40			
Drive system			В	y proximity switch	

Note: Max. discharge capacity shows when pumping clear water at $\,20^{\circ}\text{C.}$

Perfomance curves





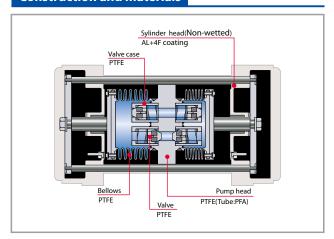


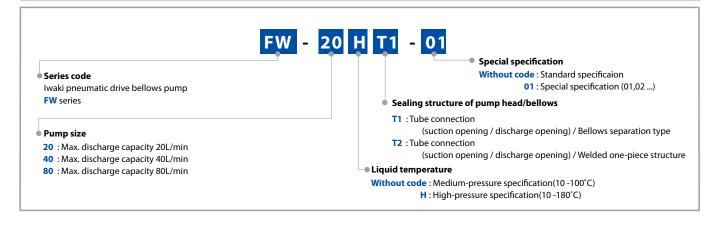
Robust bellows design provides for high pressure capability and extended service life

- The use of a thick bellows increases the pumps discharge pressure rating to as high as 0.45 MPa maximum. In addition, the bellows have three to four times longer service life than a diaphragm. This results lower case a substantially reduced downtime.
- This design is commonly used for chemical feed, the FW series can be used in high pressure and medium temperature (10 100 °C) cleaning systems as well as for the circulation of CMP slurry liquids. The FW-H with its higher temperature capability (10 180 °C) is ideal for chemical circulation in wafer cleaning applications.
- Easily adaptable fitting capability, the internally formed PFA suction and discharge tubes prevent the accumulation of particles.
- When connected to a special controller, the discharge can be monitored and controlled easily.
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.



Construction and materials



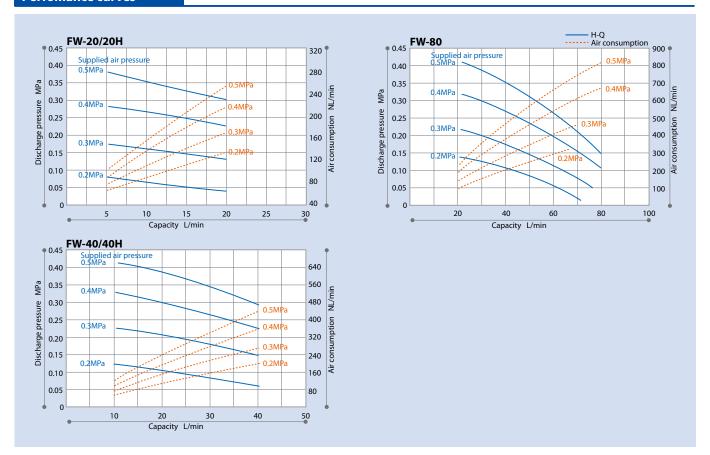


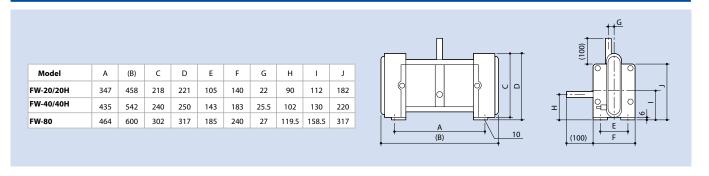


Model		FW-20	FW-40	FW-80		FW-20H			FW-40H	
Max. discharge capacity	L/min	20	40	80		20			40	
Air supply pressure range	MPa		0.2 - 0.5		0.2 - 0.5	0.15 - 0.3	0.15 - 0.2	0.2 - 0.5	0.15 - 0.3	0.15 - 0.2
Liquid temperature range	°C	10 - 100	10 - 100	10 - 80	10 - 100	101-150	151-180	10 -100	101-150	151-180
Max. air consumption	NL/min	330	480	820	330	200	140	480	300	220
Max. stroke speed	spm	120	80	80		20			80	
Pump connection size		ø19×φ16mm PFA tube	ø25×ø PFA			ø19×ø16mm PFA tube			ø25×ø22mm PFA tube	
Supplied air connection size		Rc1/4	Rc3/8	Rc1/2	Rc1/4				Rc3/8	
Ambient temperature	°C	0 - 40								
Drive system			By proximity switch							

Note: Max. discharge capacity shows when pumping clear water at 20°C.

Perfomance curves





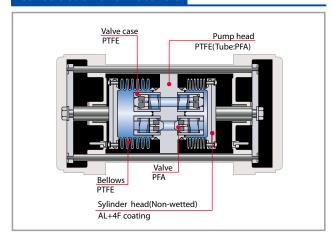


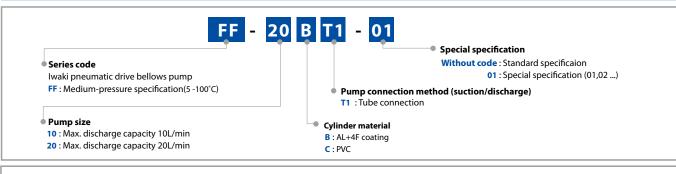
Energy efficient design consumes less air

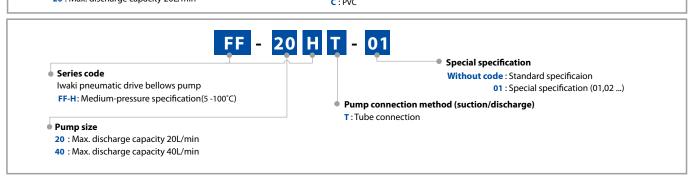
- The FF series is designed for use with medium temperature liquids (Al cylinder type: 5 to 100°C, PVC cylinder type: 5 to 50°C) and the FF-H series is designed for temperatures ranging from 20 to 180°.
- All liquid contact components are constructed of high purity fluoroesin materials with no metal or elastomers. The bellows are welded to the center eliminating leaks associated with heat cycles. The efficient design minimizes dead air volume surrounding the bellows to minimize air consumption.
- Shaft packing is easily accessible externally, no need to disassemble the pump for replacement.
- Suction and discharge fluid connections are PFA tubes and for FF models PFA tubes with special fittings are available.
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.



Construction and materials



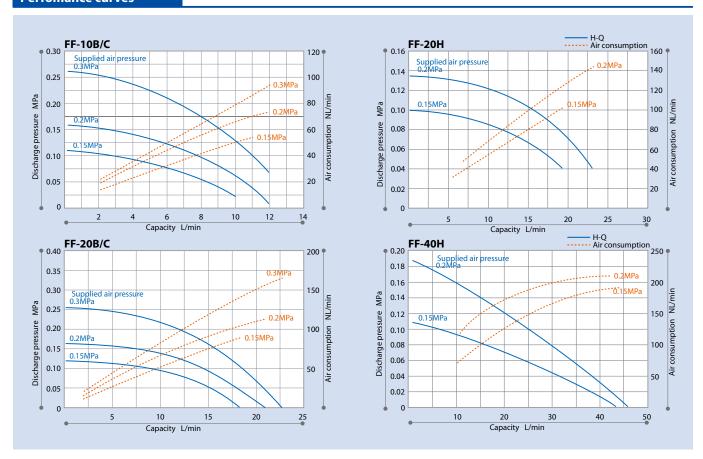


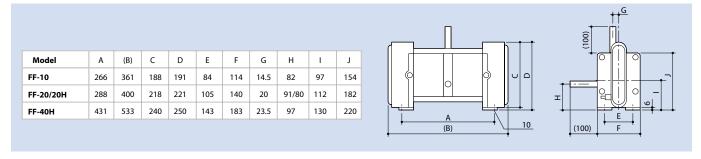


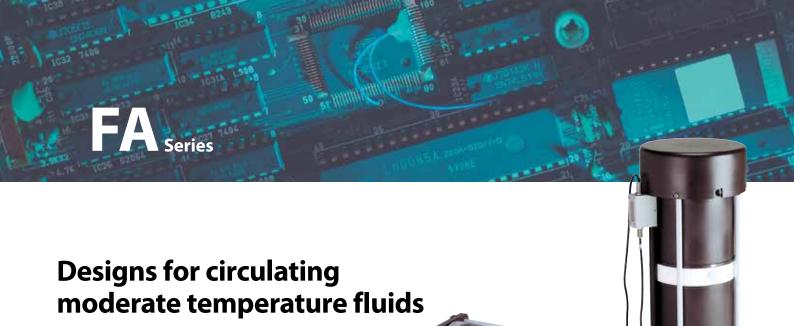
Model		FF-10BT/CT1	FF-20BT/CT1	FF-20HT	FF-40HT1	
Max. discharge capacity	L/min	10	22	20	40	
Air supply pressure range	MPa	0.15	0.3	0.15 - 0.2		
Liquid temperature range	°C	B type : 5-100	C type : 5 - 50*	20 -	180	
Max. air consumption	NL/min	90	180	150	200	
Max. stroke speed.	spm	12	20	120	80	
Pump connection size		1/2" PFA tube	3/4" PFA tube	3/4" PFA tube	ø25 x ø22mm PFA tube	
Supplied air connection size		Rc ²	/4	Rc1/4	Rc3/8	
Ambient temperature	°C	0-40				
Drive system		By proximity switch				

^{*}The cylinder of the "B" type is made of aluminum and tetrafluororesin and that of the "C" type is of PVC. Note: Max. discharge capacity shows when pumping clear water at 20°C.

Perfomance curves

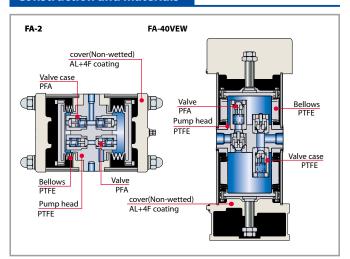


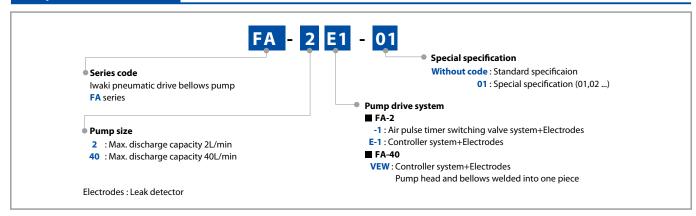




- There are two standard models available In the FA series; the FA-2E, a horizontal type for lower flow requirements and the FA-40VEW, a vertical type for a higher flow rates. A typical application for the FA-2E is in aspray system for single wafer processing while the FA-40VEW is suitable for batch cleaning of 200/300 mm wafers.
- The FA-40VEW is designed for a long service life and uses a robust bellows design suitable for continuous operation at higher discharge pressures.
- Discharge rates can be easily monitored and controlled when used with a dedicated controller
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.

Construction and materials

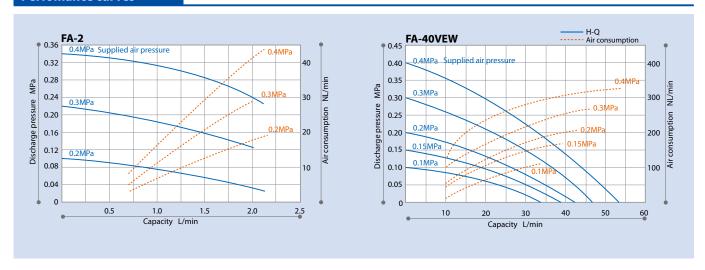


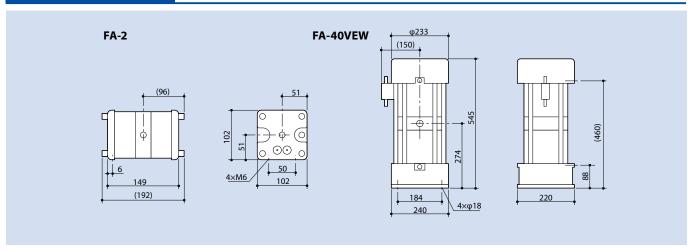


Model	FA-2E-1	FA-40VEW		
Max. discharge capacity L/min	2	40		
Max. supplied air pressure MPa	0.4			
Liquid temperature range °C	5 -	100		
Max. air consumption NL/min	50	200		
Max. stroke speed spm	150	80		
Pump connection size	Rc1/8	Rc1		
Supplied air connection size	Rc1/4	Rc3/8		
Ambient temperature °C	0 - 40			
Drive system	By proximity switch			

Note: Max. discharge capacity shows when pumping clear water at 20°C.

Perfomance curves





Option

■ Dampener

The Installation of a dampener on the discharge side of the pump will reduce pulsation and prevent particle release through filters as well as from pipe vibration.

Pulse dampeners PD-H (for wet use)

For the FS-H only

- A low cost and compact dampener.
- Liquid inside the bellows can be easily drained.
- A leak sensor is included as a standard.

Pulse dampeners PD-H1

FF

FF-H

FA

- No automatic pressure adjustment.
- The PD-H1 is a medium-pressure design for use with FF, FF-H and FA pumps.
- * Models with leak sensors are available through special order.

ent. e FA

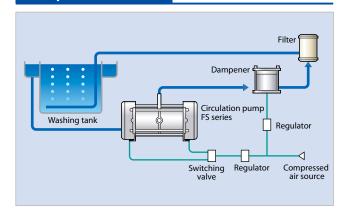
Specification

Model	PD-	15H	PD-	30H	PD-6	PD-60H	
Applicable pumps	FS-15	HT1/T2	FS-30HT1/T2		FS-60HT1/T2		
Max. supplied air pressure MPa	5 -100	101-180	5 -100	101-180	5 -100	101-180	
Liquid temperature range °C	0.3	0.2	0.3	0.2	0.3	0.2	
Supply air pressure range MPa	0.15-0.3	0.15-0.2	0.15-0.3	0.15-0.2	0.15-0.3	0.15-0.2	
Pulsation pressure range* MPa	0.04 or less						
Connection size	1/2" 3/4" φ25×φ22mm PFA tube PFA tube PFA tube						
Supply air connection size	Rc1/8						
Wet-end materials	PTFE , PFA						

*Liquid viscosity should be 50mPa•s or below.

Note: The damper cannot be used at a pressure above the level specified for the pump.

Example of installation



Automatic dampeners PDA-H1/WB/W

FS-H FW

FW-H

FF

FF

FA

 Automatic pressure adjustment minimizes downtime, eliminates manual adjustments.

- Liquid inside the bellows can be easily drained. (PDA-WB/W model)
- The PDA-H1 is a medium pressure design for use with the FF, FF-H, and FA pumps. The PDA-WB is a high-pressure design suitable for use with the FW, FW-H, and FS-H pumps. Typical applications include drug delivery and dispensing.
- The PDA-WB/W includes a leak sensor as standard. (For the PDA-H1, a leak sensor is available through special order.)
- For the PDA-WB/W, only the specified liquid pipe joint can fit the model. Please contact us before use to check if your joint is applicable.

Automatic dampeners PDA-100WBN

For the FS-100NF only

- Automatic pressure adjustment minimizes downtime, eliminates manual adjustments.
- Dampener pressure is automatically adjusted to the minimum pulse pressure even if the pump discharge load changes due to a clogged filter. The unit prevents particles being released from the filter and the pimping vibration.
- A leak sensor is included as a standard.



Model		PDA/PD-10H1	PDA/PD-40H1			
Applicable pumps		FF-10B/CT1	FF-20B/CT1 FF-20HT	FA-40VEW FF-40HT1		
Liquid temperature range	°C	20-180				
Max. supplied air pressure	MPa	0.3				
Pulsation pressure range	MPa		0.04 or less			
Connection size		1/2"	3/4"	ø25×ø22mm		
		PFA tube	PFA tube	PFA tube		
Supply air connection size		Rc1/4				
Wet-end materials		PTFE, PFA				

Model		PDA-20WB/W		PDA-40WB/W		PDA-80WB/W	
Applicable pumps		FW-20/FW-20H/ FS-15/FS-30		FW-40/FW-40H/ FS-60		FW-80	
Liquid temperature range	°C	10 -100	101-1	50	151-180	10 - 80	
Max. supplied air pressure	MPa	0.5	0.3		0.2	0.5	
Pulsation pressure range	MPa			0.06 or less			
Connection size		ø19 x ø16mm			ø22mm		
		PFA tube		PFA tube			
Supply air connection size				Rc1/4			
Wet-end materials				P	TFE, PFA		

Note 1: The damper cannot be used at a pressure above the level specified for the pump.

Note 2: The range of pulse pressures depends on conditions of usage. For further information, please call us.

Note 3: For the PDA-WB, some joints are not applicable. Please contact us for details.

Model		PDA-100WBN
Applicable pumps		FS-100NF
Max. supplied air pressure	MPa	0.7
Liquid temperature range	°C	5-60
Supply air pressure range	MPa	0.2 - 0.7
Pulsation pressure range*	MPa	0.15 or less
Connection size		25A
Supply air connection size		Rc 1/4
Wet-end materials		PTFE

*Liquid viscosity should be 50mPa-s or below.

Note 1: The max. liquid pressure is obtained when a discharge line is shut off.

Note 2: Contact us for the special damper for the FS-80NT.

■ Quick Exhaust Valve

When installed on the air exhaust lines at the pump the exhaust valve will help to reduce pulsation and prevent particle release from the filter as well as from pipe vibration.

QEV

Quick exhaust valves should be installed between the pump and the external sole-noid valve. This helps to prevent corrosion of the solenoid valve from return air. It also reduces exhaust resistance to allow the bellows to move smoothly through each cycle.



Specification

Model	Connection size	Applicable pumps
QEV-8V	Rc1/4	FW-20/20H, FF-10/20/20H, FA-2, FS-15/30
QEV-10V	Rc3/8	FW-40/40H, FF-40H, FA-40, FS-60/80N

^{*}Please contact us for quick exhaust valves for FS-100HT and the FS-100NF.

■ Pump Controller/Driver

The external solenoid valve is switched in response to signals from the built-in proximity sensors on each side of the bellows to ensure reliable operation of the pump. Two controller options are available along with one driver option.

Pump controller FDC-1 FS-H FS-N FA FW FW-H FF FF-H

■ The pump discharge rate can be monitored and maintained at a constant level by connecting an electric air regulator (optional) to the



pump air supply line. This enables stable flow and filtering even when the discharge load varies due to Increased filter resistance. In addition, the service life of the bellows will be maximized because the difference between its internal and external pressures is kept to a minimum.

- The controller can monitor the flow rate, the number of strokes, and the total count.
- The unit operates either in the AUTO mode using external signals or in the MANU mode for manual control.
- The flow rate can be set at two different values as desired.
- In addition to the sensor mode using the proximity sensors, the timer mode is included as a standard feature. This enables continued pump operation in the timer mode in case of the failure of a proximity sensor.
- The unit is equipped with various alarm displays and output functions, including leak alarm and a pump malfunction alarm.

Specifications

General specification	Power source	DC24V ±10%
	Power consumption	24VA max.
	Ambient temperature	0 – 50°C
	Working atmosphere	Without corrosive gas in surrounding areas
Input specification	Start, Alarm reset	No-voltage contact or open collector Voltage ON: 3V maximum Voltage OFF: 18V maximum
Output specification (external output)	Leak alarm Pump malfunction alarm Life alarm First alarm	Output form: NPN open collector Switching capacity: DC24V 0.4A
Dimensions in mm	W158 x D152 x H48	

■ Chemical replenishing system

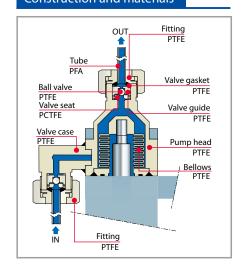
CFD-1T-B

With a resolution of up to 1.0mL/ shot fine dispense volumes can be achieved

- The resolution of the CFD-1T-B has been greatly improved compared to our existing models. The minimum flow of 1mL/shot offers greater accuracy in chemical condensation control that is required in the wafer cleaning process. The CFD-1T-B always feeds the correct quantity of chemical without overshot eliminating excess liquid wastage. In addition, the anti-siphon mechanism prevents unintentional siphoning.
- The fluoroplastic wet end (PTFE, PFA, PCTFE) is capable of handling strong acids, alkalines and hydrogen peroxide, typical chemicals required for semiconductor processing. PTFE, PFA, PP, PVC external parts and PTFE coated screws provide additional protection against chemical attack from harsh environments.
- Adjustment of the stroke length to give between 1.0-2.7mL/shot is simple by removal of the bottom cover (Factory default is 1.0mL/shot).
- Every unit is equipped with a leakage sensor to immediately detect a leak.



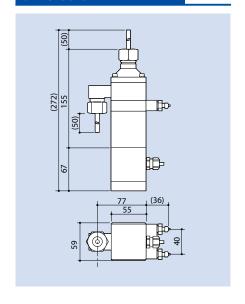
Construction and materials



Specifications Dimentions in mm

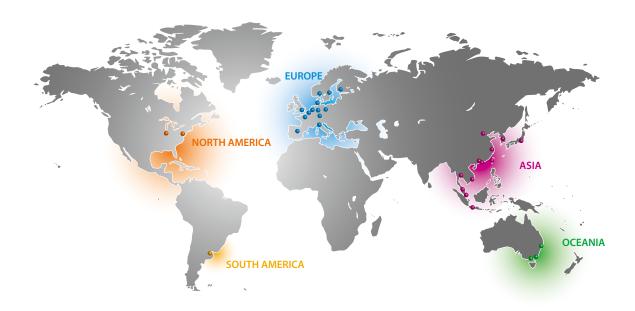
	Application	Chemical replenishing
Pump specification	Discharge capacity mL/sh	t 1mL/shot
	Max. discharge pressure M	a 0.05MPa
	Liquid temperature range	20 - 60°C
	Max.stroke speed sp	m 30spm
	Max. supply air pressure M	da 0.15 - 0.3MPa
	Max. air consumption NL/m	n 2.5NL/min
	Wet end materials	PTFE, PFA, PCTFE
	Liquid port bore	1/4"PFA tube (6.35×4.35)
	Supply air port bore	Rc1/8
	Weight	1.1kg
Photosensor specification	Model	Transmission type micro photo sensor
	Power voltage	5 - 24V DC±10%
	Output mode	NPN transistor open collector
	Allowable current	50mA or below
	Cord	5m PVC four-core cable (Outer dia.5.2mm) with 0.5 - round teminal

^{*}Please request a separate drawing for external dimensions.



^{*}An 8 mL/shot type is also available. Please contact us for more information.

IWAKI World-wide Network







IWAKI CO., LTD. 6-6 Kanda-Sudacho 2-chome Chiyoda-ku Tokyo 101-8558 Japan TEL: (81)3 3254 2935 FAX: 3 3252 8892

IWAKI has global net work.
Please find your distributor location at

WWW.iwakipumps.jp

TEL: (49)2154 9254 0 TEL: (49)2154 9254 50 FAX: 2154 9254 48 FAX: 2154 9254 55 TEL: (1)508 429 1440 TEL: (54)11 4745 4116 European office: IWAKI Europe GmbH U.S.A. : IWAKI America Inc.
Argentina : IWAKI America Inc. (Argentina Branch)
Singapore : IWAKI Singapore Pte Ltd.
Indonesia : IWAKI Singapore (Indonesia Office)
Malaysia : IWAKI Singapore (Indonesia Office)
Malaysia : IWAKI Media Singapore (Indonesia Office)
Malaysia : IWAKI Media Singapore (Indonesia Office)
Maki Fumps Co., Ltd.
China : IWAKI Pumps Co., Ltd.
Sirzi Maki Pumps (Shanghai) Co., Ltd.
Taiwan : IWAKI Pumps Taiwan Co., Ltd.
Thailand : IWAKI (Thailand) Co., Ltd.
Waki Pumps Vietnam Co., Ltd.
Waki Pumps Vietnam Co., Ltd. : IWAKI America Inc. FAX: 508 429 1386 : IWAKI Europe GmbH FAX: 2154 9254 45 FAX: (49)2154 925448 FAX: 04044 335350 FAX: 93 47 40 991 FAX: 13 67 20 30 FAX: 48 24 2346 FAX: 9 2742715 FAX: 164 49 92 73 FAX: 82 511 72922 FAX: 1743 366507 () Country codes : IWAK I Europe GmbH
:IWAK I Europe GmbH (Netherlands Branch)
:IWAKI Europe GmbH (Italy Branch)
:IWAKI Europe GmbH (Spain Branch)
:IWAKI Belgium N.V.
:IWAKI Nordic A/S
:IWAKI Suomi Oy
:IWAKI Surge A/S TEL: (65)6316 2028 TEL: (62)21 6906606 TEL: (60)3 7803 8807 TEL: (61)2 9899 2411 TEL: (852)2607 1168 TEL: (31)74 2420011 TEL: (39)0444 371115 TEL: (34)93 37 70 198 TEL: (32)13 67 02 00 Holland FAX: 6316 3221 Italy Spain Belgium FAX: 21 6906612 FAX: 3 7803 4800 FAX: 2 9899 2421 FAX: 2607 1000 Denmark Finland TEL: (45)48 24 2345 TEL: (358)9 2745810 TEL: (86)20 84350603 TEL: (86)21 6272 7502 TEL: (82)2 2630 4800 TEL: (88)28 227 6900 FAX: 20.84359181 France Norway Sweden U.K. TEL: (33)1 69 63 33 70 TEL: (47)23 38 49 00 TEL: (46)8 511 72900 TEL: (44)1743 231363 FAX: 20 64339161 FAX: 21 6272 6929 FAX: 2 2630 4801 FAX: 2 8227 6818 : IWAKI France 3.A. : IWAKI Norge AS : IWAKI Sverige AB : IWAKI Pumps (UK) Ltd. TEL: (66)2 322 2471 TEL: (84)613 933456 FAX: 2 322 2477 FAX: 613 933399 ()Country codes

Caution for safety use:

Before use of pump, read instruction manual carefully to use the product correctly.

Actual pumps may differ from the photos. Specifications and dimensions are subject to change without prior notice. For further details please contact us.

Our products and/or parts of products fall in the category of goods contained in control list of international regime for export control.

The posting and copying from this catalogue please be reminded that export license could be required when products are exported due to export control regulations of countries.

Legal attention related to export.

CAT-W 0051-06 2016.04.PDF